



**ELECTRONIC COPY**

LG777621594  
Report verification at igi.org



February 25, 2026  
IGI Report Number **LG777621594**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **14.61 X 10.11 X 6.80 MM**  
**GRADING RESULTS**  
Carat Weight **10.07 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

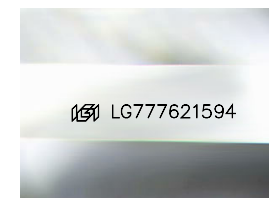
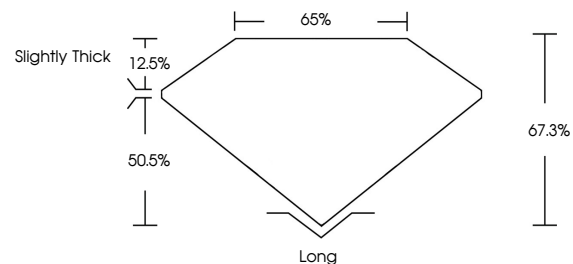
Carat Weight **10.07 CARATS**  
Color Grade **E**  
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG777621594**

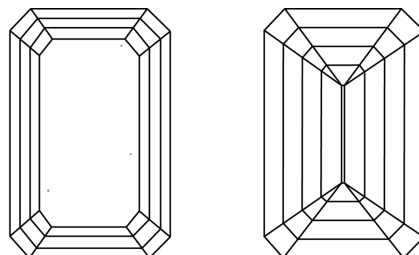
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

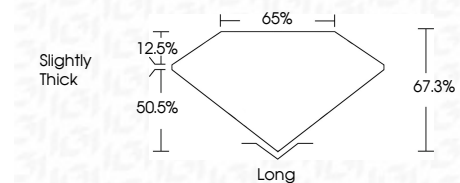
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



February 25, 2026  
IGI Report No LG777621594  
**EMERALD CUT**  
14.61 X 10.11 X 6.80 MM  
10.07 CARATS  
Color Grade **E**  
Clarity Grade **VVS 2**  
Depth **67.3%**  
Table **65%**  
Girdle **Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG777621594**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa